

Notice of References Cited

Application/Control No.

10/757,392

Applicant(s)/Patent Under
Reexamination
LEE ET AL.

Examiner

LEONARD J. WEINSTEIN

Art Unit

3746

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,428,875 B1	08-2002	Takahashi et al.	428/172
*	B	US-6,655,924 B2	12-2003	Ma, Qing	417/209
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.